## **WEST Search History**

Hide Items Restore Clear Cancel

DATE: Wednesday, September 14, 2005

Hide? Set Name Query		
DB=USPT; PLUR=YES; OP=OR		
L10	(11 same 12) and L9	7
L9	427/\$7.ccls.	86763
L8	(11 same 12) and 16	0
L7	15 and L6	1
L6	427/230,231,237.ccls.	1197
L5	11 and 12 and 13	128
L4	11 same 12 same L3	1
L3	tube or tubular or hollow near substrate	888869
L2	plasma near2 deposition	12668
L1	voltage near2 puls\$3	52190
	DB=US L10 L9 L8 L7 L6 L5 L4 L3 L2	DB=USPT; PLUR=YES; OP=OR  L10 (l1 same l2) and L9  L9 427/\$7.ccls.  L8 (l1 same l2) and l6  L7 l5 and L6  L6 427/230,231,237.ccls.  L5 l1 and l2 and l3  L4 l1 same l2 same L3  L3 tube or tubular or hollow near substrate plasma near2 deposition

**END OF SEARCH HISTORY** 

## **WEST Search History**

Hide Items Restore Clear Cancel

DATE: Wednesday, September 14, 2005

Hide? Set Name Query			Hit Count	
DB=USPT; PLUR=YES; OP=OR				
	L21	12 and 117	2	
$\Box$	L20	15 and 117	0	
	L19	117 and 15 and 16	0	
	L18	L17 and 14 and 16	0	
	L17	112 or 113 or 115	115	
	L16	ohtake adj naoto.in.	0	
	L15	kondo adj yoshimasa.in.	13	
	L14	kondo addj yoshimasa.in.	20778	
	L13	nakamura adj yukinori.in.	14	
	L12	saito adj takao in.	88	
	L11	17 and L10	1	
	L10	427/237.ccls.	415	
$\Box$	L9	17 and L8	32	
	L8	427/\$7.ccls.	86763	
$\square$	L7	11 and 15 and L6	226	
	L6	pulse near2 voltage	49650	
	L5	13 or L4	32226	
	L4	pecvd or plasma adj2 deposition	15794	
<b></b>	L3	plasma near3 (cvd or vapor adj deposition)	26916	
	L2	substrate near3 L1	5229	
	L1	tube or tubular	888569	

**END OF SEARCH HISTORY**